

Form PTO-1449

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Application Number

TSMC-02-210

10/714,304

Applicant

Chao-Chang Chen et al.

Filing Date

11/14/03

Group Art Unit

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

(Use several sheets if necessary)

U. S. PATENT DOCUMENTS

EXAMINER'S TO BE FILLED IN	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	ALNO DATE IF APPROPRIATE
ME	6350681	2/26/02	Chen et al.	438	637	2/9/01
ME	6291887	9/18/01	Wang et al.	257	758	1/4/99
ME	6287955	9/11/01	Wang et al.	438	623	11/22/00
ME	6300235	10/9/01	Feldner et al.	438	618	6/30/97

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
					YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

Michelle Estrada

DATE CONSIDERED

4/15/05

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